

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION PTO-1449</p> <p style="text-align: right;">RECEIVED TECHNOLOGY CENTER 2800 AUG 8 2001</p> <p style="text-align: left;">O P E R A T I O N S P A T E N T & T R A D E M A R K O F F I C E A U G 0 5 2 0 0 2</p>			ATTY. DOCKET NO. 25710-705	SERIAL NO. 09/894,853		
			APPLICANT Vladimir I. Vaganov			
			FILING DATE June 27, 2001	GROUP 2874		
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
JJ	4,512,036	4/16/1985	Laor	455	612	2/2/1981
JJ	5,367,584	11/22/1994	Ghezzo, et al.	385	17	10/27/1993
JJ	5,524,153	6/4/1996	Laor	385	16	2/10/1995
JJ	5,923,480	7/13/1999	Labeye	359	814	4/2/1997
JD	6,005,998	12/21/1999	Lee	385	33	2/20/1998
JD	6,192,171	2/20/2001	Goodman, et al.	385	16	2/25/2000
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
JJ	EP0883011 A1	9/12/1998	EPO	G02B	26/02	<input checked="" type="checkbox"/> <input type="checkbox"/>
JD	2 528 650		France	H04Q	3/00	<input type="checkbox"/> <input checked="" type="checkbox"/>
JD	WO 00/37849	29/6/2000	PCT	F21S	8/06	<input type="checkbox"/> <input type="checkbox"/>
JD	DE 19706053	13/8/1998	Germany	G02B	6/35	<input type="checkbox"/> <input checked="" type="checkbox"/>
JD	DE 3533286	27/3/1986	Germany	G02B	6/24	<input type="checkbox"/> <input checked="" type="checkbox"/>
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
JD	Glockner, Steffen, et al., "Micro-opto-mechanical beam deflectors.", Society of Photo-Optical Instrumentation Engineers, 36(5), pp. 1339-1345 (May 1997)					
	Huang, Long-Sun, et al., "MEMS Packaging for Micro Mirror Switches.", Electronic Components and Technology Conference., pp. 592-596 (1998)					
EXAMINER	<i>Jennifer Doan</i>		DATE CONSIDERED	02/11/04		

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.